

**Notice of References Cited**

Application/Control No.

09/595,420

Applicant(s)/Patent Under Reexamination  
BERNDT ET AL.

Examiner

Jennine M. Brown

Art Unit

1743

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,863,801	01-1999	Southgate et al.	422/101
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	C	US-5,955,028 <i>L</i>	09-1999	Chow, Calvin Y. H.	204/600
	D	US-5,571,410	11-1996	Swedberg et al.	204/451
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shoji and Esashi, "Microflow devices and systems", J. Micromech. Michroeng., 4 (1994) 157-171
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.